## Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

## **Listing of Claims:**

1. (currently amended) A method of operably interconnecting an electrooptic (EO) polymer waveguide and a passive polymer waveguide, comprising:

providing a tapered electrooptic (EO) polymer waveguide interconnection structure between an EO polymer waveguide and a passive polymer waveguide, the EO polymer waveguide including a nonlinear chromophore with a tricyanobutadiene acceptor and a phenyltetraene bridge.

2. (withdrawn) A method of fabricating a waveguide structure, comprising: coating a passive polymer lower cladding over a substrate; coating a passive core layer lower portion over the passive polymer lower cladding; curing the passive polymer lower cladding and the passive core layer lower portion; coating an electrooptic (EO) polymer layer over the passive core layer lower portion; etching the EO polymer layer to produce a tapered EO polymer layer with a tapered region;

coating an passive core layer upper portion over the tapered EO polymer layer; etching the tapered EO polymer layer to produce a rib waveguide structure; and coating a passive polymer upper cladding over the rib waveguide structure.

- 3. (withdrawn) The method of fabricating a waveguide structure of claim 2, wherein the passive polymer lower cladding and the passive core layer lower portion are cured with ultraviolet (UV) light.
- 4. (withdrawn) The method of fabricating a waveguide structure of claim 2, wherein the passive polymer lower cladding and the passive core layer lower portion are cured in a nitrogen environment.
- 5. (withdrawn) The method of fabricating a waveguide structure of claim 2, wherein the EO polymer layer is etched by oxygen plasma with a shadow mask to produce the tapered region.

- 6. (withdrawn) The method of fabricating a waveguide structure of claim 5, wherein a fixed radio frequency (RF) power and gas pressure are employed for etching the EO polymer layer.
- 7. (withdrawn) The method of fabricating a waveguide structure of claim 5, wherein a width of a gap between the EO polymer layer and the shadow mask is selected to control a taper length of the tapered region.
- 8. (withdrawn) The method of fabricating a waveguide structure of claim 2, wherein the tapered EO polymer layer is etched by:

printing waveguide patterns over the tapered EO polymer layer; and employing an oxygen reactive ion etching process to produce the rib waveguide structure.

9. (currently amended) A waveguide structure, comprising:

an electrooptic (EO) polymer waveguide <u>including a nonlinear chromophore with a tricyanobutadiene acceptor and a phenyltetraene bridge</u>;

- a passive polymer waveguide; and
- a tapered EO polymer waveguide interconnection structure between the EO polymer waveguide and the passive polymer waveguide.
- 10. (original) The waveguide structure of claim 9, wherein the EO polymer waveguide and the passive polymer waveguide provide single mode propagation, and the interconnection structure provides a coupling between the two waveguides without higher order mode coupling.
- 11. (original) The waveguide structure of claim 9, wherein an interconnection loss associated with the interconnection structure is less than 0.4 dB.
- 12. (original) The waveguide structure of claim 9, wherein the interconnection structure is vertically tapered.
- 13. (original) The waveguide structure of claim 9, wherein a taper length of the interconnection structure is 300 µm or more.

- 14. (original) The waveguide structure of claim 9, wherein a taper angle of the interconnection structure is no greater than 0.4 degrees.
- 15. (original) The waveguide structure of claim 9, wherein the EO polymer waveguide and the passive polymer waveguide are formed as rib structures.
- 16. (original) The waveguide structure of claim 9, wherein the EO polymer waveguide has a higher refractive index that the passive polymer waveguide.
- 17. (original) The waveguide structure of claim 9, wherein the passive polymer waveguide has a larger mode profile than the EO polymer waveguide.

## 18-19. (canceled)

- 20. (original) The waveguide structure of claim 9, wherein the passive polymer waveguide comprises a fluorinated polymer.
- 21. (original) The waveguide structure of claim 9, wherein the passive polymer waveguide comprises a fluorinated acrylate.
- 22. (new) A method of operably interconnecting an electrooptic (EO) polymer waveguide and a passive polymer waveguide, comprising:

providing a tapered electrooptic (EO) polymer waveguide interconnection structure between an EO polymer waveguide and a passive polymer waveguide, the passive polymer waveguide including a fluorinated acrylate.

23. (new) A waveguide structure, comprising:
an electrooptic (EO) polymer waveguide;
a passive polymer waveguide including a fluorinated acrylate; and
a tapered EO polymer waveguide interconnection structure between the EO polymer

- 24. (new) The waveguide structure of claim 23, wherein the EO polymer waveguide and the passive polymer waveguide provide single mode propagation, and the interconnection structure provides a coupling between the two waveguides without higher order mode coupling.
- 25. (new) The waveguide structure of claim 23, wherein an interconnection loss associated with the interconnection structure is less than 0.4 dB.
- 26. (new) The waveguide structure of claim 23, wherein the interconnection structure is vertically tapered.
- 27. (new) The waveguide structure of claim 23, wherein a taper length of the interconnection structure is 300 μm or more.
- 28. (new) The waveguide structure of claim 23, wherein a taper angle of the interconnection structure is no greater than 0.4 degrees.
- 29. (new) The waveguide structure of claim 23, wherein the EO polymer waveguide and the passive polymer waveguide are formed as rib structures.
- 30. (new) The waveguide structure of claim 23, wherein the EO polymer waveguide has a higher refractive index that the passive polymer waveguide.
- 31. (new) The waveguide structure of claim 23, wherein the passive polymer waveguide has a larger mode profile than the EO polymer waveguide.
- 32. (new) The waveguide structure of claim 23, wherein the EO polymer waveguide comprises a nonlinear chromophore.
- 33. (new) The waveguide structure of claim 32, wherein the nonlinear